

**Notice of References Cited**

Application/Control No.

10/780,309

Applicant(s)/Patent Under  
Reexamination  
CHENG ET AL.

Examiner

Nicholas A. Smith

Art Unit

1753

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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-4,605,565	08-1986	Nath, Prem	427/576
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Boschloo, G. et al., "Spectroelectrochemistry of Highly Doped Nanostructured Tin Dioxide Electrodes," J. Phys. Chem. B 1999, vol. 103, pp. 3093-3098.
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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